



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

PATENT
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TC 1700

Application No. : 10/019,056
Applicant : KIYOSHI DEMIZU, et al.
Filed : April 22, 2002
TC/A.U. : 2811
Examiner : Tran, Thien F.
Docket No. : 029368.50674US
Customer No. : 23911
Title : SEMICONDUCTOR WAFER AND DEVICE FOR
SEMICONDUCTOR DEVICE MANUFACTURING
PROCESS

REPLY TO OFFICE ACTION

Mail Stop: Non-Fee Amendment

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

The following remarks are respectfully submitted in response to the Office
Action dated October 15, 2003.

Amendments to the Claims are reflected in the listing of claims which
begins on page 2 of this paper.

Remarks begin on page 8 of this paper.

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